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CONFIRMATION NO. 3468

FILING FEE RECEIVED 870 No for following: *** 03/19/2002 *** 03/19/2002 Foreign Priority claimed 35 USE 119 (e.d) conditions 2											
Masayuki Naya, Kaisei-machi, JAPAN; Takashi Kubo, Kaisei-machi, JAPAN; Takashi Ito, Kaisei-machi, JAPAN; Tak	1		01/24/2002	•		GRO			DOCKET NO.		
Takashi Kubo, Kaisei-machi, JAPAN; Takashi Ito, Saitama-ken, JAPAN; Takashi Ito, Saitama-ken, JAPAN; Yoshimitsu Nomura, Saitama-ken, JAPAN; **CONTINUING DATA***********************************	APPLICANTS				· · · · · · · · · · · · · · · · · · ·						
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